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Front Matter: Volume 7589

, "Front Matter: Volume 7589," Proc. SPIE 7589, Frontiers in Ultrafast Optics: Biomedical, Scientific, and Industrial Applications X, 758901 (19 March 2010); doi: 10.1117/12.861797

SPIE.

Event: SPIE LASE, 2010, San Francisco, California, United States

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Frontiers in Ultrafast Optics: Biomedical, Scientific, and Industrial Applications X

**Alexander Heisterkamp
Joseph Neev
Stefan Nolte
Rick P. Trebino**
Editors

**24–26 January 2010
San Francisco, California, United States**

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Published by
SPIE

Volume 7589

Proceedings of SPIE, 0277-786X, v. 7589

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

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Author(s), "Title of Paper," in *Frontiers in Ultrafast Optics: Biomedical, Scientific, and Industrial Applications X*, edited by Alexander Heisterkamp, Joseph Neev, Stefan Nolte, Rick P. Trebino, Proceedings of SPIE Vol. 7589 (SPIE, Bellingham, WA, 2010) Article CID Number.

ISSN 0277-786X

ISBN 9780819479853

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

SPIE.org

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